

<b>Notice of References Cited</b>	Application/Control No. 10/526,497		Applicant(s)/Patent Under Reexamination KUBELBECK ET AL.	
	Examiner Nathan H. Empie		Art Unit 1709	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0029156	10-2001	Miyashita et al.	451/56
*	B	US-2004/0063326	04-2004	Szlufcik et al.	438/695
*	C	US-6,133,119	10-2000	Yamazaki, Shunpei	438/476
*	D	US-6,391,145	05-2002	Nishimoto et al.	156/345.12
*	E	US-5,704,992	01-1998	Willeke et al.	136/255
*	F	US-2002/0079290	06-2002	Holdermann, Konstantin	216/99
*	G	US-6,426,288	07-2002	Meikle, Scott G.	438/650
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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